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(54) SUBSTRATES AND METHOD OF MANUFACTURING SAME

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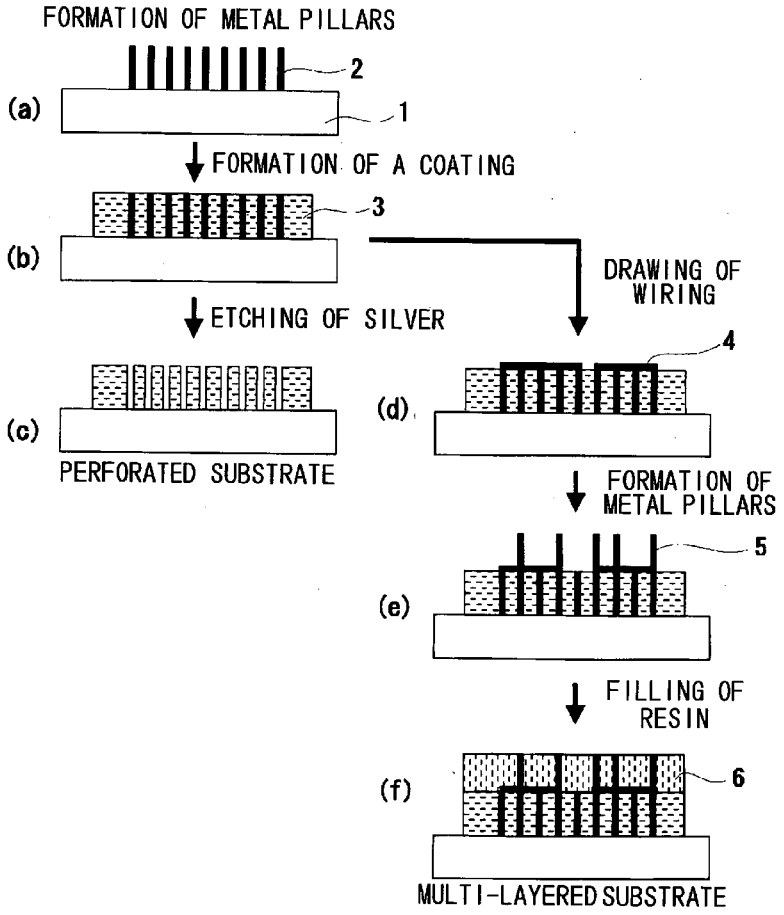
(57) **ABSTRACT**

A method of preparing substrates, including the steps of depositing metal particulates into a pillar form at a prescribed position of a substrate (**1**) by the use of a fine inkjet method, and then sintering the resultant to form a metal pillar (**2**).